**Pioneering New Horizons in Science** 



# FIB Laser lonized nano Mass Imager **GELLNER**

Key Features:

- 1. High Spatial resolution using the optimized Ga-FIB
  - lateral resolution < 40nm</li>
  - mass resolution m/ $\Delta m > 7000@m/z=56$

2. Machining and Analysis are

#### comparison : analysis of blend polymer(PS& PHS)





### available in-situ without air exposure

- little damage observation by SEM directed at the same position as FIB
- possible to analyze both the surface and cross section of a particle
- 3. Laser SNMS is available
  - significant improvement of the signal sensitivity compared to the conventional SIMS
  - high sensitive analysis for organic compound



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# TOYAMA

#### **Compatibility between High Lateral Resolution and Mass Resolution**

#### Li Ion Battery(positive electrode) \*Sample provided by AIST



SE Image



Ref.) T. Sakamoto et. all, Applied Surface Science, 2008, 255, 1617.





#### Suspended Particulate Matter (PM<sub>2.5</sub>)

#### Positive Ion (FoV 50µm)



Negative Ion (FoV 50µm)



m/z = 160





m/z=35 Cl

 $m/z=63 PO_2$ 

\*Collected near TOYAMA, R&D Center

Collected on Si-wafers set on poly carbonate filter in PM<sub>2.5</sub> standard sampler





#### FIB Fine Processing can Extend the subject to be Analyzed.





## Total ion image 1 µm Thickness of controlling agents (several 10 nm) Positive ion SIMS Visualizing distribution of base resin $(C_2)$ and cyan-pigment (CN)

Negative ion SIMS

#### **Practical Example of Laser SNMS on Polymer**







#### **B-Doped Semiconductor**





## **TOYAMA CO., Ltd.**

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